

PATENT APPLICATION

Sheet 1 of 1

FORM PTO-1449 LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	ATTY. DOCKET NO. 10004241-1	APPLICATION NO.	CONFIRMATION NO.
	APPLICANT Birecki, et al.		
	FILING DATE January 9, 2002	GROUP 2879	

J1040 U.S. PTO
10/043376
01/09/02

REFERENCE DESIGNATION

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS
<i>AW</i>	1A	5,557,596	Sep. 17, 1996	Gibson et al.		
<i>AW</i>	1B	5,835,119	Nov. 10, 1998	Samuels		
<i>AW</i>	1C	6,011,356	Jan. 4, 2000	Janning et al.		
<i>AW</i>	1D	6,184,612	Feb. 6, 2001	Negishi et al.		
	1E					
	1F					
	1G					
	1H					
	1I					
	1J					
	1K					

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	TRANSLATION	
							YES	NO
<i>AW</i>	1L	WO 00/70638	Nov 23, 2000	Vu Thien et al.				x
	1M							
	1N							
	1O							
	1P							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, etc.)

<i>AW</i>	1Q	SERIAL PROCESS FOR ELECTRON EMISSION FROM SOLID-STATE FIELD CONTROLLED EMITTERS, Binh, Vu Thien, Dupin, J.P., Thevenard, P., Purcell, S. T., and Sernet, V., J. Vac. Sci. Technol. B18(2), Mar/Apr 2000, pages 956 - 961.
<i>AW</i>	1R	FIELD EMISSION FROM ZrC AND ZrC FILMS ON MO FIELD EMITTERS, Mackie, W.A., Xie, Tianbao, Matthews, M.R., Routh, Jr., B. P., and Davis, P.R., J. Vac. Sci. Technol. B 16(4), Jul/Aug 1998, pages 2057 - 2062.
	1S	

EXAMINER

Joseph Williams

DATE CONSIDERED

8/3/04